

AF / Ifw  
IFW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2826  
Examiner: Feifei Yeung Lopez

In Re PATENT APPLICATION Of:

Applicant(s): Mineo MIURA

Serial No.: 10/588,103

Filed: July 31, 2006

For: SEMICONDUCTOR DEVICE AND  
METHOD FOR MANUFACTURING  
THE SAME

Docket No.: AI 420NP

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) **AMENDMENT AF**  
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December 29, 2008

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Examiner's Action mailed on September 29, 2008, please  
amend the above-identified application as follows:

**FEE ENCLOSED: \$** 0  
Please charge any further fee to  
our Deposit Account No. 18-0002